



U.S. Patent Application Serial No. 09/934,262  
Attorney Docket No. 03850/010001; Z8435-US/FS/OC

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TC 1700

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Oliver Kienzle et al.

Art Unit : 1756

Serial No.: 09/934,262

Examiner : John RUGGLES

Filed : August 21, 2001

Title : APPARATUS AND METHOD FOR EXPOSING A RADIATION SENSITIVE  
LAYER BY MEANS OF CHARGED PARTICLES AS WELL AS A MASK  
FOR THIS PURPOSE

Commissioner for Patents

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PATENT TRADEMARK OFFICE

**REPLY UNDER 37 CFR § 1.111**

In response to the Restriction Requirement dated September 12, 2003, please  
amend the application as follows and consider the included remarks.